# **Studies for the Phase-2 ATLAS ITk pixel upgrade**

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## **Brief self-introduction**

• Kyushu University



- Summer 2013: MEG Experiment @ PSI
- 2013-2014: muon g-2/EDM Experiment @ J-PARC
- 2015 : ATLAS @ CERN
  - SCT Operation
  - Displaced heavy neutral lepton analysis
- Tokyo Institute of Technology, University of Geneva
  - 2019 : ATLAS @ CERN
    - ITk Upgrade
- LPSC
  - 2022 2023 : ITk Upgrade

























## LHC and ATLAS



- 2008 2025
- <µ>~30
- 1 x 10<sup>34</sup> cm<sup>-2</sup>s<sup>-1</sup>
- 400 fb<sup>-1</sup> (190 fb<sup>-1</sup> so far)













## LHC and ATLAS



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## **High Luminosity LHC**





## HL-LHC

- 2008 2025
- <µ>~30
- 1 x 10<sup>34</sup> cm<sup>-2</sup>s<sup>-1</sup>
- 400 fb<sup>-1</sup> (190 fb<sup>-1</sup> so far)
- 2028 ~
- <µ>~200
- 7.5 x 10<sup>34</sup> cm<sup>-2</sup>s<sup>-1</sup>
- 4000 fb<sup>-1</sup>

#### LHC / HL-LHC Plan







### **Requirement for the pixel detector and** its readout becomes demanding

#### Radiation tolerance

- Current ID Pixel designed for ~ 400 fb<sup>-1</sup>
- Bandwidth saturation
  - Current ID designed to accommodate  $<\mu>$  ~ 50 at 2 x 10<sup>34</sup> cm<sup>-2</sup> s<sup>-1</sup>





## **High Luminosity LHC**





## HL-LHC





## by an all silicon Inner Tracker



## **ATLAS Inner Tracker Upgrade**

- New Inner detector have to cope with the HL-LHC environment
  - Better radiation tolerance
    - Fluence of 2 x  $10^{16} n_{eq}/cm^2$ , 4000 fb<sup>-1</sup>
  - Faster readout
    - 5 Gbit/s per data link
  - Finer granularity
    - keep ~ 1% occupancy

- Covered a Covered a Readout Readout a [n] Pixel
  - L1 Tr



	Current ID	ITk
area (Pix) [m <sup>2</sup> ]	1.9	13
area (Strip) [m²]	60	160
channels (Pix)	~9.2 x 10 <sup>6</sup>	5 x 10 <sup>9</sup>
channels (Strip)	~ 6 x 10 <sup>6</sup>	~ 50 x 10 <sup>6</sup>
coverage	2.5	4.0
size [µm²]	50 x 400, 50 x 250	50 x 50, 25 x 100
rigger [kHz]	100	1000





## **ITk Pixel Detector**

- Key Concepts
  - Inner 2 layers are replaceable
  - Inclined modules
    - Minimise material and maximise acceptance
  - Larger covered area: 13 m<sup>2</sup>,  $|\eta| < 4$ 
    - Consists of ~ 10000 modules
  - Low material budget
  - 3D and planar sensors
  - Serial powering
  - Common front-end chip for all layers





r [mm]

#### **Radiation length**





## **ITk Pixel Sensor**

- Main change in sensor technology is the increase in the required level of tolerance to radiation
- 3D sensors: radiation hardness, low power dissipation
  - At the innermost layer (L0)
  - in the triplet modules
- Planner sensors: high fabrication yield and lower costs
  - In all other layers (L1-L4)
  - In the quad modules



Luminosity	Layer	Location	R	z	Fluence	
			(cm)	(cm)	$(10^{14} n_{eq}/cm^2)$	(
$2000 \ {\rm fb}^{-1}$	0	flat barrel	3.9	0.0	131	
			4.0	24.3	-	
		inclined barrel	3.7	25.9	123	
			3.7	110.0	-	
		end-cap	5.1	123.8	68	
$2000 \ {\rm fb}^{-1}$	1	flat barrel	9.9	24.3	27	
		inclined barrel	8.1	110.0	35	
		end-cap	7.9	299.2	38	
$4000~{ m fb}^{-1}$	2-4	flat barrel	16.0	44.6	28	
		inclined barrel	15.6	110.0	30	
		end-cap	15.3	299.2	38	







## **Planar Sensor**

### **IBL**

- Thickness of 200 µm  $\bullet$
- $50 \times 250 \ \mu m^2$  pixel cells lacksquare
- n-in-n  $\bullet$

### ITk

- $50 \times 50 \ \mu m^2$  pixel cells  $\bullet$
- n-in-p  $\bullet$



#### n-in-p technology

- Well proven and understood technique
- Single sided process (simple production, low cost)

## Thickness of 100, 150 µm

### **Required Performance**

- Hit efficiency > 97% (after irradiation)
- Bias voltage at end of life up to:  ${\color{black}\bullet}$ 
  - 600 V for 150 µm sensor lacksquare
  - 400 V for 100 µm sensor lacksquare







10

## **3D Sensor**

- 3D sensor used in the innermost layer
  - 150 µm active thickness + 100 µm support wafer
  - 50 x 50 µm<sup>2</sup> (endcap region)
  - 25 x 100 µm<sup>2</sup> (barrel region)
  - More radiation tolerant



#### **Required Performance**

- Hit efficiency > 97% (after irradiation)
- Low operational bias voltage: 80-140 V
- Low power dissipation









11

## **ITk Front-End Chip**



#### **RD53A** Prototype

- 3 different type FEs are on a single chip
- 400 x 192 pixels
- $50 \times 50 \,\mu m^2$

Example of square pixel on sensor above

Bump bond location

#### **RD53 Collaboration**

- ATLAS and CMS
- 65 nm TSMC technology (130 nm for IBL)
- 50 µm minimum pitch
- Shunt LDO implementation for compatibility with Serial Powering







## **ITk Pixel Module**



### **Flexible PCB**

**ASIC** 

### **Silicon Sensor**

### Hybridization

- Fine-pitch bump-bonding
- Bump deposition, UBM, flip chip

Wire-bond



### Quad module $(40 \times 40 \text{ mm}^2)$

#### **Flexible cable**

- $50 \times 50 \ \mu m^2$  pixel lacksquare
- 1.28 Gb/s per lane



13

## **Module QC**

- All modules have to pass "module QC"
  - Many institutes (> 20) are joining in the Production



### **Difficulty for QC tests**

- Perform comparable tests with variety of  $\bullet$ testing setup
- Properly handle testing data to compare between different stage/sites





## Database





### **Central DB: ITk Production DB**

• Storage for all data of ITk

### Local DB:

• Temporary storage of each site







## **Data Flow**





## **Local Data Base**

### **NoSQL** Database

- Favoured due to its flexibility compared to SQL DB
- Data is stored as a "json" format ("document")

### SQL

- Relational
- Structured data
- Vertically scalable
- Table based

#### NoSQL

- Non-relational
- Unstructured data
- Horizontally scalable
- Document, key-value, graph, or widecolumn





#### Application **Collection Retrieved document** id: 2001, id: 2001, Module\_ID: XXX, Module\_ID: XXX, Serial: Hoge, Serial: Hoge, Test\_ID: ZZZ, Location: Huga, Temp\_1: [,,,,], Humi\_1: [,,,,] document MongoDB API





## Structure of LocalDB





## Local DB Viewer

### Custom Web application based on Flask

	ican List						
op i age > J							
can Li	st						
put keyword	ls 💿 Pa	artial match 🔿 Pe	erfect match	Search			
			1 2 3 4 5	5 6 7 8 9 10 11 12 13 14 15	*		
		Test Data					
Module Name	Chip Name	Test Type	User	Site	Date	Link	Tag J: Creat
KEKQ07	chip1 chip2 chip3 chip4	std_analogscan	atlasj	atlaspc9.kek.jp	2021/08/19 18:07:25	result page	🗣 hoge
KEKQ07	chip1 chip2 chip3 chip4	std_digitalscan	atlasj	atlaspc9.kek.jp	2021/08/19 18:06:54	result page	
KEKQ07	chip1 chip2 chip3 chip4	std_analogscan	atlasj	atlaspc9.kek.jp	2021/08/19 13:07:26	result page	
KEKQ07	chip1 chip2 chip3 chip4	std_digitalscan	atlasj	atlaspc9.kek.jp	2021/08/19 13:07:04	result page	
KEKQ07	chip1 chip2 chip3 chip4	std_analogscan	atlasj	atlaspc9.kek.jp	2021/08/19 12:53:58	result page	
KEKQ07	chip1 chip2 chip3 chip4	std_digitalscan	atlasj	atlaspc9.kek.jp	2021/08/19 12:53:35	result page	
KEKQ07	chip1 chip2 chip3	std_analogscan	atlasj	atlaspc9.kek.jp	2021/08/19 12:46:57	result page	

KEKQ07	chip2 chip3 chip4	std_analogscan	atlasj	atlaspc9.kek.jp	2021/08/19 18:07:25	result page
KEKQ07	chip1 chip2 chip3 chip4	std_digitalscan	atlasj	atlaspc9.kek.jp	2021/08/19 18:06:54	result page
KEKQ07	chip1 chip2 chip3 chip4	std_analogscan	atlasj	atlaspc9.kek.jp	2021/08/19 13:07:26	result page
KEKQ07	chip1 chip2 chip3 chip4	std_digitalscan	atlasj	atlaspc9.kek.jp	2021/08/19 13:07:04	result page
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KEKQ07	chip1 chip2 chip3 chip4	std_digitalscan	atlasj	atlaspc9.kek.jp	2021/08/19 12:53:35	result page
KEKQ07	chip1 chip2 chip3 chip4	std_analogscan	atlasj	atlaspc9.kek.jp	2021/08/19 12:46:57	result page

Top Page > Component List > Scan List > Component > Scan Result

#### Component: 20UPGR10099999 C Component page of ITkPD

Current Stage: MODULEWIREBONDPROTECTION

Result: 133

🌣 Informatio	on			
ltem	Value			
Serial Number	20UPGR10099999			
Component Type	module			
FE type	RD53A			
Children	20UPGFC9999995 2	20UPGFC9999996	20UPGFC9999997	20UPGFC9999998

🌣 Result		
🗅 Scan		🗎 Outp
Кеу	Data	Data
runNumber	133	Туре
testType	std_analogscan	ctrlCfg
stage	MODULEWIREBONDING	dbCfg
component	20UPGR10099990 20UPGFC9999995 20UPGFC9999996 20UPGFC9999997	siteCfg userCfg
	20UPGFC9999998	boforoC
startTime	2021/08/05 00:48:14	Deforec
finishTime	2021/08/05 00:49:09	
user	kinoshita	
site	gemini	- (1 () (
targetCharge	-1	afterCig
targetTot	-1	
exec	-r configs/controller/emuCfg_rd53a.json -c db-data/connectivity.json -s configs/scans/rd53a/std_analogscan.json -W	
stopwatch	analysis: 548 config: 533 processing: 2 scan: 49035	Occupa
QC	False	
environment	False	L1Dist
plots	OccupancyMap L1Dist EnMask	
passed	True	
qcTest	False	EnMask
qaTest	False	
summary	False	

Output Data				
Data				
Туре	Format	Chip	Display	Download 📥
ctrlCfg	json			A
dbCfg	json			*
siteCfg	json			*
userCfg	json			±
scanCfg	json			
beforeCfg	json	20UPGFC9999995		*
		20UPGFC9999996		*
		20UPGFC9999997		*
		20UPGFC9999998		*
afterCfg	json	20UPGFC9999995		*
		20UPGFC9999996		*
		20UPGFC9999997		*
		20UPGFC9999998		*
OccupancyMap	json	20UPGFC9999995		*
		20UPGFC9999996		*
		20UPGFC9999997		*
		20UPGFC9999998		*
L1Dist	json	20UPGFC9999995		*
		20UPGFC9999996		*
		20UPGFC9999997		*
		20UPGFC9999998		*
EnMask	json	20UPGFC9999995		*
		20UPGFC9999996		*
		20UPGFC9999997		<u>*</u>
		20UPGFC9999998		<b>A</b>







## Local DB Viewer

#### Dynamically generate plots by ploty







## **Environmental Data**

## () influxes the series database for environmental monitoring



Grafana: Open source analytics and interactive visualisation web application





## **QC Helper**

#### Data uploader for non-electrical tests

🔴 🕘 🐘 🔀 QC Helper			🕅 Wirebonding information	
Choose your inspection	on	Input Wir	ebonding inform	ation
Serial Number : practice Test Stage : practice		Machine used : Operator Name :		
Test name	Upload status in localDB	Institution of Operator :		<b></b>
• Mass Measurement	Practice	Bond wire batch :	ТВА	
<ul> <li>Wirebond pull tests</li> </ul>	Practice	Bonding jig :		Chassa fila
<ul> <li>Wirebonding Information</li> </ul>	Practice	Bond program :		deaC
<ul> <li>Parvlene Properties</li> </ul>	Practice	Humidity :		%RH
O Glue Information Module+Flex Attach	Practice			
O Thermal Cycling	Practice	comment :		
<ul> <li>Optical Inspection</li> </ul>	Practice	Back		<u>N</u> ext
<ul> <li>Metrology</li> </ul>	Practice	Current user : practice	pra	ctice mode
O Sensor IV at 30 degC	Practice		V main ny	_
<ul> <li>Sensor IV at 20 degC</li> </ul>	Practice			
O Sensor IV at -15 degC	Practice		Metrology	
O SLDO VI	Practice	Result file:		<u>C</u> hoose file
O RD53A pull-up resistor FE	Practice			
○ IrefTrim FE	Practice	Comment :		
<ul> <li>PCB-Bare Orientation isNormal</li> </ul>	Practice			
Back	Next	Back		Next
Current user : practice	practice mode 📈	Current user : practice		practice mode



### We're also trying to automatize visual inspection...

	oage: 12/36
	Plating
heckbox.	Plating
	4
	Next
	1.





## **YARR - DAQ system**

- PCIe based high-speed DAQ system
  - FPGA just aggregates data from FE ASICSs, everything sophisticated is done by its corresponding software





## **RD53A Testing Setup**





## **RD53A Testing Setup**

### Cooling system for the quad module









## **Peltier Control and Temperature Monitoring**

#### TEC-1089-SC-PT1000



#### **PID Control**

- Two temperature sensors as references
  - PT1000 for vacuum chuck
  - NTC for cold plate





#### SHT85

- High-accuracy RH&T sensor for demanding measurement & test applications
- Typical accuracy of ± 1.5 %RH and ± 0.1 °C
   Pin-type packaging for easy integration and replacement
- Fully calibrated, linearized, and temperature compensated digital output
- On-package membrane protected by exclusive license for several patents<sup>1</sup>







## **Temperature Control and Monitoring**

#### Overview of testing setup @ UniGe



#### Controlled by GUI

		D	CS Co	ntroller _ 🗆 🗙			D	CS Con	troller	-
Summary	Temperature	LV	HV		Summary	Temperature	LV	HV		
Temperatur	e and Dewpoint		F	Peltier Controler	ch1:	(	off		$\bigcirc$ on	l
				Statuc	1.0			<b>v</b> [	1.0	
Module:	22.40	) de	egC 📗	Status.	ch2:	(	off (		$\bigcirc$ on	
		_		O Init O Ready   Run O Error	1.0			v	1.0	
Vacuum Cl	hunk: -5.40	de	egC		ch3:	(	off (		$\bigcirc$ on	
Cold Plate	11.32	2 de	eqC	Applied Voltage: 1.82 V	1.0			V	1.0	
					ch4:	(	off (		$\bigcirc$ on	l
Inside Coo	ling Unit: 6.71	de	egC	Current: 1.22 A	1.0			v	1.0	
Relative H	umidity: 11.19	%			Set Volta	ge and Current				
Dewpoint:	-21.9	7 de	egC	Target Temperature: -10 degC	⊖ ch1	$\bigcirc$ ch2	С	ch3	$\bigcirc$ ch4	🔿 all
								v		
show	nfo ref	resh		Reset Apply					OFF	0

HMP4040

#### Monitored by Grafana (recorded in the influxDB)







## Loaded Cell Module





## **Module Temperature**

#### **Temperature Sensors of the Module**

- 2 NTCs on the PCB
- 4 NMOS temperature sensors in each ASIC
  - These sensors are available only when chip turns on





$$\Delta V = N_f \times \frac{kT}{q} \times \ln R$$

 $V_1 = M_{\text{right}}$  Biased at 1 x l<sub>p</sub>

$$\Delta V = V_2 - V_1$$

 $V_2 = M_{right}$  Biased at 15 x Ip

How to calibrate temperature sensors in the ASIC?





## **Temperature Sensor Calibration**

Leakage current of a silicon sensor depends on its temperature

$$\frac{I(T_2)}{I(T_1)} = \left(\frac{T_2}{T_1}\right)^2 e^{-\frac{E_g(T_2)}{2kT_2} + \frac{E_g(T_1)}{2kT_1}}, E_g(T) = E_g(0) - \frac{\alpha T^2}{T + \beta}$$



Able to calibrate each sensor with the accuracy of  $\pm 1.3$  C





## **Upstream Data Transmission**









## **PPO Prototype**

- First inclined PP0 prototype
  - based on design done for services PDR
  - Adapted from L4 to L3

#### LV round-trip resistance







![](_page_31_Figure_8.jpeg)

![](_page_31_Picture_9.jpeg)

## **Readout Test for PPO Prototype**

• Testing with 2 quad modules

![](_page_32_Figure_2.jpeg)

![](_page_32_Figure_3.jpeg)

![](_page_32_Picture_5.jpeg)

![](_page_32_Picture_6.jpeg)

## **Readout Test for PPO Prototype**

• Testing with 2 quad modules

![](_page_33_Figure_2.jpeg)

![](_page_33_Figure_3.jpeg)

2000

1000

1000

1500

2000

2500

3000

Threshold [e]

### Get equivalent results as module stand alone test

![](_page_33_Picture_5.jpeg)

![](_page_33_Picture_6.jpeg)

## Conclusion

- There are many activities toward Phase-II ATLAS ITk Upgrade
  - Preparing for the mass production of Pixel detector
  - Testing setup, procedure, database, and so on...
- Real production phase is approaching!!

- Thank you for your attention!!
- ご清聴有り難うございました。

![](_page_34_Picture_8.jpeg)